ABSTRACT

There is provided a method of manufacturing an electrostatic chuck which is free from fluctuations in performance or incomplete detachment from the beginning of use, without being influenced by the impurities that remain on the surface of, or in the inside of, a dielectric layer at the time of manufacturing thereof, in case the dielectric layer which comes into contact with an article to be held by the electrostatic chuck is made of silicone rubber or resin. Before assembling the dielectric layer (6) into the surface of a base (3) having disposed thereon an electrode (5), or after the dielectric layer (6) has been assembled into the surface of the base (3), a step is performed in which a heating plate (7) that has been heated to a predetermined temperature is pressed against the contact surface of the dielectric layer (6).

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